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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: I-Sheng Liu et al.

Title: SOURCE/DRAIN ADJUST IMPLANT

Application No.: 10/753,673 **Filing Date:** January 7, 2004

Examiner: Johannes P. Mondt **Group Art Unit:** 2826

Docket No.: M-15281US **Confirmation No.:** 6785

Irvine, California
July 25, 2005

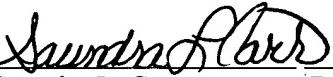
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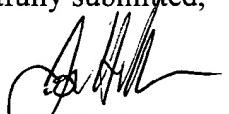
As requested by the Examiner in the Office Action dated February 25, 2005, enclosed herewith are the formal drawings (2 sheets) to be filed in the above-referenced patent application. If you have any questions, please do not hesitate contacting the undersigned counsel for applicant.

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Saundra L. Carr

7-25-05
Date of signature

Respectfully submitted,


Jonathan W. Hallman
Attorney for Applicant(s)
Reg. No. 42,622
Dated: July 25, 2005

LAW OFFICES OF
MACPHERSON KWOK CHEN
& HEID LLP

1762 TECHNOLOGY DRIVE
SUITE 226
SAN JOSE, CA 95110
(408) 752-7040
FAX (408) 392-9262